Continuous Time-of-Flight Ranging Using a MEMS Diffractive Subwavelength Period Grating (de)Modulator

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Abstract—We present a time-of-flight (TOF) ranging experiment based on optical mixing. The key component in this experiment is the optical (de)modulator. Consequently we also report on the design, fabrication, and characterization of a microelectromechanical system diffractive grating (de)modulator with a subwavelength period. The obtained results are an important step toward an optical mixing based TOF 3-D imaging system, which we will further develop in our future work.

Index Terms—Microelectromechanical devices, optical modulation, 3-D imaging, time-of-flight (TOF).

I. INTRODUCTION

CONTINUOUS time-of-flight (TOF) range finding systems for 3-D imaging rely on measuring the phase shift of a modulated carrier wave induced by traveling time [1]. Essentially the 3-D imaging sensor consists of two components: a light source and a detector. The emitted light is modulated and travels toward the scene where it is reflected and travels back toward a detector. At the detector side a homodyne phase delay detection is performed, thus retrieving information on the traveling time and hence providing 3-D imaging ability.

This homodyne phase shift detection scheme requires mixing of the received (reflected) signal with the initial modulation frequency of the emitted light signal, so by consequence the mixer/(de)modulator acts as the key component in this detection scheme. Two main research tracks can be identified: modulators in the electrical domain [2], [3] and modulators in the optical domain [4]. The former is the standard approach in commercially available 3-D imaging sensors [5]; the latter allows combining off-the-shelf high-performance image sensors with a separate optical modulator, ultimately providing very high image resolution and system performance compared to the electrical mixing approach.

In this letter, we focus on the second approach and present a microelectromechanical system (MEMS) optical diffractive grating modulator with a grating period smaller than the wavelength used. With this approach, we obtained sufficient modulation depth (35%) and modulation frequency (3.73 MHz). Moreover, we applied this component in a TOF experiment and delivered a proof-of-principle for TOF ranging with optical mixing by characterizing fibers with different lengths successfully. To our knowledge, this is the first successful demonstration of TOF with optical mixing based on MEMS.

II. OPTICAL MEMS (DE)MODULATOR

A. MEMS Diffractive Grating Modulator Principle

As shown in Fig. 1, the device basically consists of a diffractive grating, which is undereacted over a certain region (free-standing section). The top layer in which the grating is defined is electrically isolated from the substrate by a buried oxide layer (and by air in the freestanding section). The diffractive grating itself is formed by two intersecting combs that are also electrically isolated from each other and have separate metal contacts.

By applying a voltage between such a contact and the substrate, a closing gap capacitor is formed and the corresponding beams are pulled toward the substrate. This way we create an alternating pattern of deflected and not-deflected beams, such that the incident light experiences a change in reflection. Since the grating pitch is smaller than the wavelength, only one diffraction order is present in contrast to the classical grating light valve [6].

B. Modulator Design

Application of both a DC and AC voltage (frequency f) will cause a sinusoidal force with magnitude \( F_\omega = C V_\text{AC} V_\text{DC}/h \) (driving capacitance \(C = \varepsilon_0 \varepsilon_0 \text{vacuum permittivity} \)), and hence the diffractive grating acts as a modulator \((V_\text{AC} = 8 \text{ V}, V_\text{DC} = 300 \text{ V}, l = 22 \mu \text{m, } h = 2 \mu \text{m})\). Using an analytical spring-mass-damper model [7] and the above-mentioned parameters, we find a theoretical resonance frequency of 3.4 MHz and a typical vibration amplitude of 240 nm (Young’s modulus for monocrystalline silicon in \(< 100 > \) direction = 130 GPa, mass density \(= 2400 \text{ kg/m}^3\)). Taking into account this deflection and using a rigorous coupled-wave analysis software tool,
Using an optical detector + electrical spectrum analyzer, the optical CW power $P_{\text{CW}}(= P_{\text{init}} + \alpha R_{\text{CW}})$ was recorded in parallel with the modulated optical power $P_{\text{mod}}(= P_{\text{init}} + \alpha R_{\text{mod}})$ so finally the modulation depth $P_{\text{mod}}/P_{\text{CW}} = R_{\text{mod}}/R_{\text{CW}}$ could be determined in function of the frequency of the AC-voltage while the voltage amplitudes were kept constant at $V_{\text{AC}} = 8$ V and $V_{\text{PC}} = 300$ V. Sweeping the modulation frequency we attained a maximal modulation depth of 35% at 3.73 MHz which corresponds quite well to the previously calculated theoretical natural beam frequency (3.4 MHz). The deviation between theory and experiment for the modulation depth might be explained by the fact that the curvature of the beams was ignored in the optical simulation.

III. TIME-OF-FLIGHT

A. TOF Principle

In principle, the experimental setup for our TOF experiment is very similar to the setup used for the characterization of the modulator, however, the light source itself is now modulated and reaches the mixer with a phase delay $\varphi(L)$ dependent on the fiber length $L$ (with $c$ the speed of light in vacuum and $n \approx 1.45$ the mode index of the optical fiber)

$$P_{\text{init}} = P_{\text{AVG}} + P_{\text{AMP}} \sin (2\pi f t - \varphi[L])$$

$$\varphi[L] = 2\pi f n L / c$$

Now we apply a phase difference $\psi$ between modulated laser source and mixer such that $R(t) = R_{\text{CW}} + R_{\text{mod}} \sin(2\pi f t + \psi)$ and substitute the modified expression for $R(t)$ together with (2) into (1). Applying some elementary goniometric calculus and grouping all time-dependent terms in a rest term $O(t)$ gives the following result for the demodulated light:

$$P_{\text{OUT}} = \alpha R_{\text{CW}} P_{\text{AVG}} + \frac{1}{2} \alpha R_{\text{mod}} P_{\text{AMP}} \cos(\varphi + \psi) + O(t).$$

Since the output power has a CW component $\sim \cos(\varphi + \psi)$, we can calculate $\varphi$ by measuring the CW power in $P_{\text{OUT}}$ for alternating $\psi(0^\circ, 90^\circ, 180^\circ, 270^\circ)$ with a power detector and substituting the values in the following formula:

$$\varphi = \arctan \left( \frac{(P_{270^\circ} - P_{90^\circ})}{(P_{0^\circ} - P_{180^\circ})} \right).$$

This procedure is known as the four-bucket algorithm [9]. Using (3), it is possible to extract the fiber length $L$.

B. Choice of Modulation Frequency/Modulator Technology

A maximum nonambiguous distance $L_{\text{NA}}$ is determined by replacing $\varphi$ with $2\pi$ in (3) for phase can only be measured unambiguous over a range of 2$\pi$. For a modulation frequency $f = 3.73$ MHz, we find $L_{\text{NA}} = c/(nf) \approx 55$ m. Since $L_{\text{NA}}$ increases with lower $f$, one might think that $f$ should be chosen as low as possible; however, this is not the case because a larger...
$L_{NA}$ would result in a lower depth resolution. A typical compromise value for $f$ lies in the megahertz range, so MEMS are a good choice for implementing the optical modulator.

### C. Experimental Results

The setup is shown in Fig 3. The light of the modulated laser source ($\lambda = 1542$ nm, $\pm 2$ mW) is focused with a lensed fiber onto the grating modulator and the CW component of the demodulated light is measured for different $\psi$.

Finally, from our measurement data, we calculated the fiber length and compared with the real (known) value. The experiment was repeated for fibers of different lengths (10, 20, 30, 40, 50 m). The results are summarized in Fig. 4.

### IV. DISCUSSION

From Fig 4, we see that we found a good match between the experimentally extracted fiber lengths and the real fiber lengths. For example, for the 40-m fiber, the relative error between the real value and the average measured value is only 0.6%. Given the fact that there is also uncertainty on the exact mode index of the fiber (estimated at $n \approx 1.45$), this is a good result and a significant improvement compared to our previous work [10].

The critical point to achieve low standard deviation (error bars) on the measurement data is to reduce the random (not related to TOF) fluctuations in the CW power level. For this reason, the lensed fiber needs to be antireflection-coated because otherwise the cavity that is formed between the lensed fiber and the grating causes fluctuations in the power level.

Furthermore, it is interesting to note that the standard deviation tends to be significantly bigger for the fibers with lengths 10, 30, and 50 m compared to the fibers with lengths 20 and 40 m (e.g., $\sigma_{30\ m} = 6.9$ m versus $\sigma_{40\ m} = 2.1$ m). In the case of 20 and 40 m, only one fiber was involved while the other lengths where achieved using a concatenation of multiple fibers. Hence we suspect that the reflections at the connectors cause fluctuations in the CW power level due to cavity effects.

Since we only need to detect a CW power, it is possible to replace the optical power detector in this scheme with a camera. In this case, each pixel allows extraction of the light traveling distance and hence a powerful 3-D imaging ability. In order to process a complete scene, the fiber system should be replaced with a free space lens system and beam splitter. Hence the reflection-related noise might decrease; however, the optical power budget will now depend on the source and system étendue and the lens system collection efficiency.

### V. CONCLUSION

We have demonstrated a TOF ranging system with optical mixing using a MEMS diffractive grating (de)modulator. In our future work, we will work toward a free space demodulating system, which will (in combination with an off-the-shelf image sensor) result in a 3-D imaging sensor.

**REFERENCES**


